## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Somenath Mitra et al.

Application No.: 10/735,989

Group Art Unit: 3742

Examiner: Fastovsky, Leonid

Filing Date: December 15, 2003

Docket No: 436/12

For: MICROMACHINED HEATERS FOR

**MICROFLUIDIC DEVICES** 

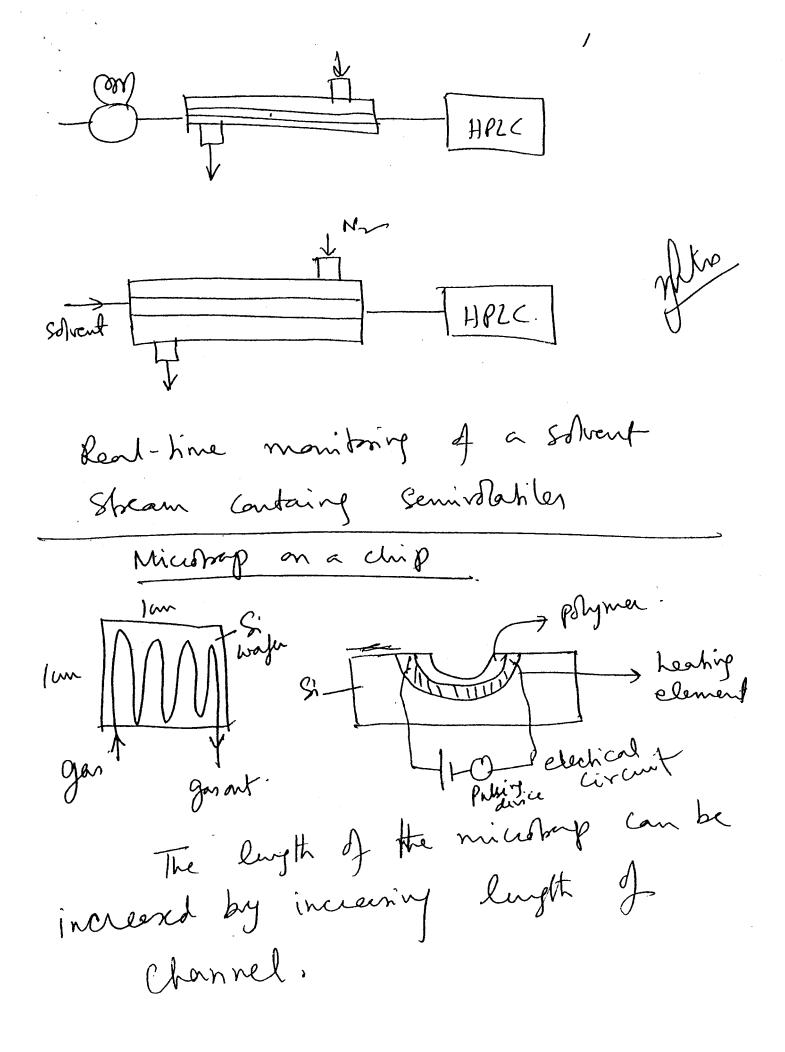
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **DECLARATION UNDER 37 CFR §1.131**

- I, Somenath Mitra, do hereby declare and say:
- 1. I am a named inventor of the above-captioned patent application.
- 2. I conceived the idea and fully documented my conception at least as early as June 1998. Attached are pages from my lab notebook which were generated in or around 1998.
- 3. The lab notebook pages describe a microheater comprising at least one microchannel formed on a substrate and a conductor disposed in the at least one microchannel.
- 4. From the time I conceived the invention until the time the patent application was filed I worked diligently on the completion of the invention.
- 5. I further declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and that these statements were made with the knowledge that willful false statements and the likes so made are punishable by fine or imprisonment, or both under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patents issuing thereon.

Somenath Mitra

ate: 8/5/, 200



ne heating element com be a layer of metal or Delectrical heating paint, like the men we we had before from ando stores. Two nivror images can be put an sop of each other

· chip -0/25/98 Si water , mak, Littgraphy etch Channel Spin coat

heating film

of canducting polymen. ar Implant or sputter a metal. spin cont polymen or deposit by means Band mirror (mofes

6/27/98 rd Senser 8.88 all a newafer 1 cm Singer Senser Senser 1 cm Sing 3 cm 3 cm 2 cm Some architechne, 1st device as microhap, second on GC column, Sensor as detector. Micosop - high capacity, pulsed operation Gel column - Low capacity, heat byp temperature proframning. Increase convent slowly through the conductive layer, leading to temperature ramp.

Micator & Column on device. enting Section for (Sh)

The hearing clement & polymers are different in the two sections. In the first section with a high copacity phymen that retains strongly In the latter section its a GC, so, low capacity. Healing for the first section for injection/pulsity. The latter such in for slow heating & desuperative of Sides with